

Notice of References Cited	Application/Control No. 10/801,830	Applicant(s)/Patent Under Reexamination CHEVALLET ET AL.	
	Examiner John Kim	Art Unit 1723	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,679,245	10-1997	Manica, Keith	210/134
*	B	US-2005/0043666	02-2005	Pan, Gang	604/006.08
*	C	US-5,536,412	07-1996	Ash, Stephen R.	210/645
*	D	US-4,960,408	10-1990	Klainer et al.	604/6.08
*	E	US-6,582,385	06-2003	Burbank et al.	604/5.04
*	F	US-6,561,997	05-2003	Weitzel et al.	604/6.09
*	G	US-6,787,040	09-2004	Radunsky et al.	210/651
*	H	US-6,730,233	05-2004	Pedrazzi, Renato	210/739
*	I	US-5,366,630	11-1994	Chevallet, Jacques	210/645
*	J	US-5,211,849	05-1993	Kitaevich et al.	604/5.04
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.